

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	0	cleaning with etching and chamber and oxide adj3 gas and metal with layer and (("CL.sub2."CL2 chloride) with (triflouromethane CHF3 "chf.sub3."))	US-PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/15 14:22
2	BRS	L2	0	cleaning with etching and chamber and oxide adj3 gas and metal with layer and (("CL.sub2."CL2 chloride) with (triflouromethane CHF3 "chf.sub3.")) .clm.	US-PGPUB	2005/12/15 14:19
3	BRS	L3	0	cleaning and etching and chamber and oxide adj3 gas and metal and layer and (("CL.sub2."CL2 chloride) with (triflouromethane CHF3 "chf.sub3."))	US-PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/15 14:20
4	BRS	L4	0	clean\$3 and etch\$3 and chamber and oxide and gas and metal and layer and (("CL.sub2."CL2 chloride) and (triflouromethane CHF3 "chf.sub3."))	US-PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/15 14:21

SMG

	Type	L #	Hits	Search Text	DBs	Time Stamp
5	BRS	L5	0	clean\$3 and etch\$3 and oxide and gas and metal and layer and (("CL.sub2."CL2 chloride) and (triflouromethan e CHF3 "chf.sub3."))	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:22
6	BRS	L6	0	oxide and gas and metal and layer and (("CL.sub2."CL2 chloride) and (triflouromethan e CHF3 "chf.sub3."))	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:23
7	BRS	L7	2154 38	oxide and gas and metal and layer	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:22
8	BRS	L8	156	cleaning with etching and chamber and oxide adj3 gas and metal with layer	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:22

	Type	L #	Hits	Search Text	DBs	Time Stamp
9	BRS	L9	261	clean\$3 with etch\$3 and chamber and oxide adj3 gas and metal with layer	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:30
10	BRS	L1 0	0	(("CL.sub2."CL2 chloride) and (triflouromethan e CHF3 "chf.sub3."))	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:23
11	BRS	L1 1	169	(("CL.sub2." CL2 chloride) and (triflouromethan e CHF3 "chf.sub3."))	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:24
12	BRS	L1 2	2	9 and 11	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT	2005/12/1 5 14:24

	Type	L #	Hits	Search Text	DBs	Time Stamp
13	BRS	L1 3	1	(clean\$3 with etch\$3 and chamber and oxide adj3 gas and metal with layer).clm.	US- PGPUB	2005/12/1 5 14:30